

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :

Mei Zhu et. al.

Serial No. :

09/966,651

Filed :

September 28, 2001

For :

High Frequency Electrochemical Deposition

Group Art Unit :

1741

Examiner :

Atty Docket :

56785.US / 01-446

STATUS REQUEST

Hon. Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

Applicants request a status of the above referenced application. Please mail the status notification to the address stated below.

Respectfully submitted,

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Date: 31 JAN 03

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